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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **MIYAZAKI, Ryuuji, et al.**

Group Art Unit: 3753

Serial No.: 10/500,464

Examiner: Not yet assigned

Filed: July 14, 2004

P.T.O. Confirmation No.: 5285

FOR: **HEAT SINK WITH INCREASED COOLING CAPACITY AND
SEMICONDUCTOR DEVICE COMPRISING THE HEAT SINK**

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: January 24, 2006

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on **July 14, 2004** in the U.S. Patent and Trademark Office and
to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit
Account No. 01-2340.

Respectfully submitted,

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